Correlation of Surface Morphology and Interfacial Adhesive Behavior between Cellulose Surfaces

Citation

Year
2019

Version
Publisher's PDF (version of record)

Link to publication
TUTCRIS Portal (http://www.tut.fi/tutcris)

Published in
Langmuir

DOI
10.1021/acs.langmuir.8b03503

Copyright
https://creativecommons.org/licenses/by/4.0/

License
CC BY

Take down policy
If you believe that this document breaches copyright, please contact cris.tau@tuni.fi, and we will remove access to the work immediately and investigate your claim.
Correlation of Surface Morphology and Interfacial Adhesive Behavior between Cellulose Surfaces: Quantitative Measurements in Peak-Force Mode with the Colloidal Probe Technique

Yuli Lai,†,∥ Hao Zhang,‡,∥ Yasuhide Sugano,§ Hui Xie,*∥ and Pasi Kallio*†

†Micro- and Nanosystems Research Group, Faculty of Medicine and Health Technology, Tampere University, P.O. Box 692, 33101 Tampere, Finland
‡The State Key Laboratory of Robotics and Systems, Harbin Institute of Technology, Harbin 150080, PR China
§Department of Industrial Chemistry, Faculty of Engineering, Tokyo University of Science, 1-3 Kagurazaka, Shinjuku-ku, Tokyo 162-8601, Japan

ABSTRACT: A better understanding of cellulose–cellulose interactions is needed in applications such as paper making and all-cellulose composites. To date, cellulose–cellulose studies have been chemistry-oriented. In these studies, the sample surfaces have been modified with different chemicals and then tested under an atomic force microscope (AFM) using a colloidal probe (CP). Studies of cellulose–cellulose interaction based on sample morphology and mechanical properties have been rare as a result of the complex surface structure and the soft texture of the cellulose. The current surface interaction models, such as the Johnson–Kendall–Roberts (JKR) model in which the studied bodies are assumed to have smooth surfaces, can no longer fully reveal the interfacial behavior between two cellulose surfaces. Therefore, we propose a new type of contact model for rough–rough interaction by dividing the surface contacts into primary and secondary levels. The main idea of the new model is to take into account local individual contact details between rough surfaces. The model considers the effect of the surface topography by including the asperities and valleys on a cellulose sphere used as the colloidal probe in imaging the topography of a cellulose membrane (CM). In addition, the correlation between the surface morphology and adhesion is studied. To verify the importance of including the effect of the surface roughness in contact analysis and validate our hypothesis on the correlation between the surface morphology and adhesion, an extensive set of experiments was performed. In the experiments, a combination of the AFM peak-force mode (PFM) and the CP technique was employed to acquire a massive amount of information on cellulose–cellulose interactions by measuring the adhesion among six CSs of different sizes and a CM.

INTRODUCTION

Cellulose, as the most abundant polymer in plants and trees, is used as a raw material, for example, in paper, biocomposite, and textile products. In these various products involving cellulose, the interfacial interactions are of particular interest because they influence not only the mechanical properties of the product but also its production. By means of paper products, their mechanical properties depend as much on the network structure and the bond strength between cellulose fibers as on the single cellulose fiber strength. The importance of the interface was also emphasized in a recent review on all-cellulose composites in which the authors concluded that further insights into the interfacial phenomena between cellulosic surfaces are needed to fully utilize the benefits and potential of monocomponent composites.

Natural cellulose fibers (NCFs) are porous microscale objects. Unlike most artificial fibers, such as glass fibers, which have a unified shape and a smooth surface, each NCF has a unique shape with a rough surface. These characteristics make it very difficult to directly measure the cellulose surfaces’ interactions using individual NCFs for two reasons. First, the random shape of NCF is a significant obstacle for sample positioning and grasping during the measurement operation; second, the porous and rough surface leads to an inaccurate estimation of the interfacial contact area, which is later required to normalize the force result. Therefore, this study employs the technique of colloidal probe (CP) atomic force microscopy (AFM), which was introduced by Butt and Ducker et al. for interaction measurements. In the CP technique, either a tip of an AFM probe is modified to a semispherical shape or a single spherical colloid is glued to a tipless AFM probe cantilever. Because the NCF is a cellulose-based
material, cellulose microspheres (CS) are selected to mimic NCF in the measurements. Compared to the measurement of interactions between individual NCFs, the CP technique is more reliable and convenient to employ as the cellulose CP can be pushed against a cellulose substrate to obtain the force data. So far, this technique has been widely adopted in interaction force studies of cellulose-based materials, as well as many other materials.

Nowadays, the most common method used for measuring interaction forces between different material surfaces involves employing the CP technique under normal AFM working modes, such as the pull-off mode (POM) and the force volume mode (FVM). These techniques collect single force curves or an array of force curves, which are plots of force as a function of the probe displacement along the axis perpendicular to the surface (z axis). Obtaining an adhesion map requires acquiring adhesion data from thousands of force curves. Therefore, it takes several hours to complete the process because each force curve generally takes approximately 1 s to collect. In addition, environmental scanning electron microscopy (ESEM), which is known for its precise control of environmental conditions (e.g., humidity, temperature), is also used to measure interaction forces, especially the adhesion between cell substrates. However, ESEM is not suitable for making quantitative data measurements in batches.

Nevertheless, the newly developed peak-force mode (PFM) reduces the whole mapping process to several minutes by acquiring the force curves at high speed with high precision force control. Moreover, when using the PFM, it is possible to correlate the adhesion with the substrate morphology because the PFM can acquire substrate topography images of fairly high resolution synchronously with the force data, which cannot be done by using the POM or FVM. Therefore, on the basis of the aforementioned facts, we propose to use the CP technique with the PFM (CP-PFM) for the cellulose–cellulose interaction study.

In many of the previous cellulose-related force studies (shown in Table 1), the measurements were conducted in aqueous solution or using surface-treated/coated cellulose materials. Different from the previous studies, we use pure cellulose without any surface treatment or coating, and the measurements are carried out in air. The main purpose of this study is to create a new model of rough–rough surface interaction and correlate the adhesion to the morphology of the sample substrate. To the best of our knowledge, this is the first paper to use the CP-PFM technique for such a purpose in cellulose research.

In this article, CSs of different sizes were selected to prepare the CPs for adhesion measurements. Qualitative measurements were performed between each cellulose CP and a pure cellulose membrane (CM). A customized dual-probe AFM was programmed and employed to complete the preparation of the CP and conduct the PFM for high-speed measurements of interaction properties. The extensive quantity of data obtained in this article provides an opportunity to connect the adhesive behavior between cellulose surfaces based on their morphology with statistically higher reliability, which previous studies have not done because of limitations in the available techniques.

### THEORETICAL ASSUMPTION AND MODELING

#### Effect of Tip Asperities

It is known that the quality of an obtained topography image depends largely on the morphology of the probe tip employed for scanning. According to the tip-broadening effect, an AFM probe with a smaller tip reveals more precise information about the surface properties and produces images with features much closer to the real topography of the sample than using a probe with a larger tip. Therefore, the topography images obtained by two CPs having the same size should have approximately the same

---

**Table 1. Catalog of Cellulose Adhesion Research**

<table>
<thead>
<tr>
<th>Material Contact Mode</th>
<th>Measured Force</th>
<th>Technique</th>
<th>Surface Treatment</th>
<th>Environment</th>
<th>Adhesion and Surface Morphology Correlation</th>
<th>Refs</th>
</tr>
</thead>
<tbody>
<tr>
<td>c–c</td>
<td>s–p</td>
<td>interaction</td>
<td>scanning probe</td>
<td>yes</td>
<td>aqueous</td>
<td>no</td>
</tr>
<tr>
<td>c–o</td>
<td>s–p</td>
<td>friction</td>
<td>yes</td>
<td>yes</td>
<td>no</td>
<td>6</td>
</tr>
<tr>
<td>c–c</td>
<td>s–p</td>
<td>interaction</td>
<td>pull-off</td>
<td>no</td>
<td>aqueous</td>
<td>no</td>
</tr>
<tr>
<td>c–s</td>
<td>s–s</td>
<td>interaction</td>
<td>scanning probe</td>
<td>yes</td>
<td>air and aqueous</td>
<td>no</td>
</tr>
<tr>
<td>c–c</td>
<td>s–p</td>
<td>interaction</td>
<td>pull-off</td>
<td>no</td>
<td>aqueous</td>
<td>no</td>
</tr>
<tr>
<td>c–o</td>
<td>s–p</td>
<td>friction</td>
<td>no</td>
<td>no</td>
<td>aqueous</td>
<td>no</td>
</tr>
<tr>
<td>c–c</td>
<td>s–s</td>
<td>friction</td>
<td>no</td>
<td>no</td>
<td>aqueous</td>
<td>no</td>
</tr>
<tr>
<td>c–c</td>
<td>s–p</td>
<td>interaction</td>
<td>pull-off</td>
<td>no</td>
<td>air</td>
<td>no</td>
</tr>
<tr>
<td>c–o</td>
<td>s–p</td>
<td>interaction</td>
<td>pull-off</td>
<td>no</td>
<td>air</td>
<td>no</td>
</tr>
<tr>
<td>c–c</td>
<td>s–p</td>
<td>interaction</td>
<td>peak force</td>
<td>no</td>
<td>air</td>
<td>yes</td>
</tr>
</tbody>
</table>

*Cellulose–cellulose, c–c; cellulose–other material, c–o; sphere–sphere, s–s; sphere–plane, s–p.*

---

**Figure 1.** Cellulose membrane topography obtained by applying (a) a normal AFM probe, (b) CP with a 2.5 μm CS, and (c) CP with a 2.5 μm BS. Scan area: 15 μm × 15 μm.
number of feature details and differ largely from the images acquired with a standard AFM tip.

However, when compared to the topography images obtained using a borosilicate sphere (BS) tip, the topography provided by a CS tip reveals more details and information and is similar in quality to images scanned by a standard AFM tip (Figure 1). This observation suggests that the interaction behavior measured with a rough-surface CS is governed by the tiny asperities on the surface of the CS (Figure 2). Figure 3 demonstrates AFM images of the BS (a) and CS (b) tips. The substantial difference between these two tips is the asperities which are found on the CS surface, whereas the BS surface is significantly smoother. Therefore, it is reasonable to believe that more information and geometrical details can be obtained by using a CS-based CP instead of a CP that has a smooth surface similar to BS.

Contact Model. In a previous research paper, Kumar et al. established a model between a smooth sphere and a substrate with a rough surface, where the morphology of the substrate surface was simplified and represented by primary and secondary asperities and valleys. In our case, there are primary and secondary asperities and valleys in both the CS and CM because they both have rough surfaces. In addition, so far the most commonly used model for demonstrating the interaction between two surfaces is the Johnson–Kendall–Roberts (JKR) model. The JKR model is applied normally on smooth−smooth surface contact and it is an equilibrium model, which cannot accurately describe the interaction of a rough−rough surface with a short contact time of less than 1 s. However, it is still efficient to use the JKR to estimate the adhesion value at each contact spot and predict the adhesion dynamics as a function of CS size when analyzing the contact surfaces that are fragmentary at primary and secondary levels.

At the primary level, there are two scenarios in terms of the contact relationship for a sphere and a substrate: the sphere interacts either with the primary asperity (Figure 4a) or with the primary valley (Figure 4b,c) on the substrate. When the sphere is in contact with the primary asperity of the substrate, the adhesion between them can be calculated with eq 1. When the interaction occurs between the sphere and the primary valley, the adhesion can be estimated using eq 2 (if sphere radius $r \leq$ primary asperity/valley radius $R$) and eq 3 (if $r > R$).

![Figure 2. Tip asperities.](image)

![Figure 3. Three dimensional topography of the BS (a) and CS (b) tips. Scan area: 2 $\mu$m $\times$ 2 $\mu$m.](image)

![Figure 4. Contact modes between CS and CM at the primary level: (a) sphere−asperity contact, (b) sphere−valley contact when $r \leq R$, and (c) sphere−valley contact when $r > R$.](image)

In eqs 1−4, $W$ is the work of separating the contact surfaces, $F_{pa}$ is the primary asperity−asperity adhesion force, $F_{pva}$ is the primary asperity−valley adhesion force when $r \leq R$, $F_{pv}$ is the primary asperity−valley adhesion force when $r > R$, $F_1$ and $F_2$ are adhesion at points 1 and 2, respectively, and $F_{pv}$ is the primary asperity−valley adhesion force in general.

At the secondary level, the interactions are caused by the surface roughness of the sphere and the substrate. Similar to the primary level, there are also two contact scenarios: asperity−asperity and asperity−valley, as shown in Figure 5. When the influences from the primary asperities and valleys are...
neglected, the secondary asperity–asperity adhesion can be expressed as eq 5. The secondary asperity–valley adhesion can be demonstrated by eqs 6 or 7.

\[
F_{sa} = \frac{3}{2} \pi W \frac{r R}{r + R_s}
\]  
(5)

\[
F_{svs} \geq \frac{3}{2} \pi W k
\]  
(6)

\[
F_{svl} = 3 \pi W \frac{r R}{r + R_s}
\]  
(7)

Then it is obvious that

\[
F_{sa} < F_{sv}
\]  
(8)

In eqs 5–8, \( r_s \) and \( R_s \) are the equivalent radii of the secondary tip asperity and the secondary substrate asperity/valley, respectively. \( F_{sa} \) is the secondary asperity–asperity adhesion force, \( F_{svs} \) is the secondary asperity–valley adhesion when \( r_s \leq R_s \), \( F_{svl} \) is the secondary asperity–valley adhesion when \( r_s > R_s \), and \( F_{sv} \) is the secondary asperity–valley adhesion force in general.

On the basis of these equations, it is easy to deduce that the CP experiences a higher adhesion force on valleys than on asperities at both primary and secondary levels. This is different from the case in ref 35 where no adhesive interactions occurred in the secondary valleys of the substrate surface because the sphere surface was considered to be smooth.

**Theoretical Scanning Model and Surface Height–Adhesion Plots.** According to the contact model provided above, when a CP is employed to conduct the topography scanning, the output of the measurements should follow the patterns shown in Figure 6. At the primary level, only when the radius of the CP is no larger than the radius of the primary valley, the CP can reach the bottom point \( H_2 \) of the surface primary valley. Otherwise, the CP cannot come into contact with the bottom of the valley. In this case, the surface height value acquired by the AFM system is \( H'_2 \) instead of the actual height \( H_2 \) because of the tip size effect. At the secondary level, it is extremely difficult to predict the actual scanning pattern because there can be multiple tip asperities in contact with the substrate surface at the same time. However, an approximation of the pattern can be drawn as presented in Figure 6e,f. Additionally, it is already known from the contact model that the adhesion is always higher in surface valleys at both primary and secondary levels for rough–rough surface interaction. Therefore, it is reasonable to describe the surface height–adhesion plots as those in Figure 6g,h, where the adhesion force experiences peak values at valleys.

### EXPERIMENTAL SECTION

**Materials.** The adhesion force among six CSs of different sizes and pure (100%) CMs was measured using the CP technique in the PFM. To make the CM, dry cellulose (Sigma-Aldrich) was added and dissolved in 1.3 M NaOH solution. The mixture was then dropcast onto a glass surface. Afterward, the sample was left to dry before being immersed in a H₂SO₄ bath. Finally, an excess amount of deionized (DI) water was used to wash the regenerated samples before they were stored in water for later use. Using such a fabrication method, CM should have no other components other than cellulose.

Nonchemically treated CSs (CELLULOBEADS D-10 and D-30) were provided by KOBO. Six standard AFM probes (HQ: NSC18/Al BS, Mikromash) with a spring constant of 2.8 N/m were modified with a focused ion beam (FIB) to remove the tips for CP preparation. A customized dual-probe AFM system was employed to prepare the CP and measure the adhesion force between the CSs and CM. More details are given, along with a description of the system setup, in the following paragraphs.

**Experimental Setup.** As shown in Figure 7, this system consists of two probe holders (PH I and PH II), which are installed on two 3-
DOF micropositioning stages (MS I and MS II), an optical lever system with a laser and a position-sensitive detector (PSD), and two optical microscopy systems (top view and side view). The sample table is fixed on a 3-DOF nanopositioning stage (NS) located on a 3-DOF micropositioning stage (MS III). The colloidal probe can be made by simultaneously manipulating MS I and MS II under the two optical microscopy systems. (More details are given in the next section.) During the measurement, an arbitrary waveform generator (AWG) is used to drive a piezoelectric actuator of PH II to realize the periodic motion of the probe used in the PFM scanning. The cantilever deflection is measured with the PSD and fed to the force–distance (FD) controller, which controls the maximum force between the probe and the sample and also records the adhesion force between them using a reference force value. The maximum force applied to the probe is referred to as the peak force, and the adhesion force is equal to the force at which the probe detached from the sample.

Preparation of the Colloidal Probe. First, the CS samples were placed into an acetone bath, followed by washing with an excess amount of DI water several times before being dried in an oven at 60 °C for 12 h. After the CS samples were ready, they were transferred onto a clean cover glass, which was mounted on the sample table. A selected CS was picked up by applying negative pressure through a microcapillary. When the CS picking was completed, the microcapillary was removed from PH I under negative pressure while still holding the CS on its head and carefully suspending it in a Petri dish. Then, a thin tungsten wire, cast with a small droplet of epoxy resin glue (ergo 7200), as well as the aforementioned standard AFM probe, were mounted on PH I and PH II, respectively. A tiny amount of glue was transferred from the wire to the front of the AFM cantilever surface by adjusting the positions of the PH I. After the drop of glue was deposited onto the AMF cantilever, the tungsten wire was removed and the microcapillary with the chosen CS was remounted onto PH I. The CP preparation was completed by moving the CS on the microcapillary tip onto the AFM cantilever surface and approaching the drop of glue until a part of the sphere was merged with the glue, thereby guaranteeing a rigid connection between the probe and the sphere. After 24 h, the customized AFM colloidal probe was ready, given that the glue was completely solidified. The process is depicted in Figure 8.

The Cleveland method was used to calibrate the spring constant of the prepared CPs. This method requires measuring the resonance frequencies of the CP before and after adding a known mass to the end of the cantilever. (In our case, this mass was a tin sphere with a radius of 20 μm.) As a result, the real spring constant can be calculated from the measurement data. The CS diameters were measured in a scanning electron microscope (SEM), shown in Figure 9. Subsequently, the CS radius and the actual spring constants of the CPs are presented in Table 2.

Table 2. Calibrated Actual Spring Constants of Prepared CPs with Different CS Sizes

<table>
<thead>
<tr>
<th>tip</th>
<th>CS₁</th>
<th>CS₂</th>
<th>CS₃</th>
<th>CS₄</th>
<th>CS₅</th>
<th>CS₆</th>
</tr>
</thead>
<tbody>
<tr>
<td>CS radius (μm)</td>
<td>3.3</td>
<td>5.3</td>
<td>7.48</td>
<td>13.18</td>
<td>14.35</td>
<td>16.54</td>
</tr>
<tr>
<td>actual spring constant (N/m)</td>
<td>1.92</td>
<td>2.35</td>
<td>2.07</td>
<td>2.51</td>
<td>1.50</td>
<td>2.21</td>
</tr>
</tbody>
</table>

provide a vertical oscillation so that the CP is driven to approach and retract the sample surface repeatedly at high frequency. Meanwhile, the responding force curves are recorded by the FD controller system as the output of the interaction between the CP and the CM. Each force curve represents one test cycle including the peak force and the adhesion force as illustrated in Figure 10. The adhesion, referred as the pull-off which is the lowest point of the force curve, is obtained by means of a conventional lowest point search. In our tests, the peak force was set to 15 nN. The number of sampling points for each force curve was 1000, and the scan rate was 1 line/s. The oscillation
frequency of the probe was kept constant at 1 kHz, whereas the oscillation amplitude was different for each CS−CM pair. The main idea is to keep the amplitude larger than the value of the adhesion force/probe stiffness such that the adhesion value can be correctly detected. In these tests, the oscillation amplitude was between 20 and 30 nm. The obtained topography and adhesion images have a resolution of 256 pixels × 256 pixels (step size, 10 nm). Temperature and humidity were controlled to 23 ± 1 °C and 14 ± 1%, respectively, in order to prevent unnecessary disturbances from the environment.

**Surface Homogeneity.** The adhesion value depends largely on the surface energy and morphology of the sample. When the sample has a homogenous surface, the adhesion values between the sample and the same probe should be similar at different locations on the sample surface and vice versa. The adhesion histograms (Figure 11) indicate the homogeneity of the sample surface. Therefore, the adhesion difference should be small for the same CS probe at different locations on the CM sample.

### RESULTS AND DISCUSSION

**Comparison to the Johnson–Kendall–Roberts Model.** The adhesion force of six CS−CM pairs were obtained by using PFM, which returned an excessively large amount of data for plotting adhesion histogram for each sample pair as shown in Figure 12a−f. Table 4 presents both the experimental and theoretical adhesion forces for each CS−CM pair, where the theoretical values were calculated from the JKR model using eq 9. Subsequently, all of these data were

<table>
<thead>
<tr>
<th>location</th>
<th>1</th>
<th>2</th>
<th>3</th>
<th>4</th>
<th>5</th>
</tr>
</thead>
<tbody>
<tr>
<td>CS−CM (nN)</td>
<td>84.98</td>
<td>75.66</td>
<td>83.31</td>
<td>76.63</td>
<td>72.62</td>
</tr>
<tr>
<td>standard deviation (nN)</td>
<td>41.40</td>
<td>42.06</td>
<td>44.31</td>
<td>40.91</td>
<td>37.16</td>
</tr>
<tr>
<td>BS−CM (nN)</td>
<td>33.77</td>
<td>34.31</td>
<td>33.62</td>
<td>29.23</td>
<td>35.85</td>
</tr>
<tr>
<td>standard deviation (nN)</td>
<td>20.94</td>
<td>24.28</td>
<td>25.43</td>
<td>20.73</td>
<td>27.86</td>
</tr>
</tbody>
</table>

Figure 11. Adhesion histograms and Gaussian fit curves of CS−CM and BS−CM at five different locations.

Figure 12. Adhesion histograms and Gaussian fit curves of CS₁−CS₆: (a−f).

Figure 13. Experimental and JKR adhesion forces.
plotted in the same figure (Figure 13) to facilitate the comparison. Compared with the JKR model, where the adhesion force constantly increases with an increase in the sphere radius, the increasing trend for the measured adhesion force is interrupted after the sphere radius reaches 13.18 μm. The reasonable explanation for this phenomenon is that the size of CS at this point becomes comparable to the size of the primary valleys on CM. Consequently, the average contact area between the CS and CM reaches an interim maximum level. As a result, the adhesion force is maximized at this moment. Once the size of CS becomes higher (at 14.35 μm) than the primary valleys, the adhesion force drops from the previous maximum point (at 13.18 μm) and starts to increase again as the size of the CS increases (from 14.35 to 16.54 μm).

Table 4. Experimental and JKR Model Calculated Adhesion Forces of Differently Sized CSs

<table>
<thead>
<tr>
<th>tip</th>
<th>CS₁</th>
<th>CS₂</th>
<th>CS₃</th>
<th>CS₄</th>
<th>CS₅</th>
<th>CS₆</th>
</tr>
</thead>
<tbody>
<tr>
<td>experimental adhesion force (average) (nN)</td>
<td>136.79</td>
<td>184.78</td>
<td>365.11</td>
<td>576.61</td>
<td>365.93</td>
<td>457.72</td>
</tr>
<tr>
<td>standard deviation (nN)</td>
<td>70.95</td>
<td>65.55</td>
<td>94.80</td>
<td>119.93</td>
<td>185.58</td>
<td>100.54</td>
</tr>
<tr>
<td>JKR adhesion force (nN)</td>
<td>1197.4</td>
<td>1923.1</td>
<td>2714.1</td>
<td>4782.4</td>
<td>5207.0</td>
<td>6001.6</td>
</tr>
</tbody>
</table>

Figure 14. Measurements conducted among CS₁, CS₂, CS₃, CS₄, CS₅, CS₆, and CM: (a−f) topography, (g−l) adhesion map, (m−r) four-dimensional images combining the three-dimensional topography with the adhesion (color bar), (s−x) and the correlated surface height and adhesion comparison plots. The minimum height is fixed to zero in s−x. Scale bar in a−l: 500 nm.
the measured adhesion is larger on CS4 than on CS5 and
neat cellulose sphere (both having a diameter of 10
μm). We have studied the relationship between the contact time and the
work of adhesion and surface height, the normalized adhesion (Fadhesion/cm)
as a function of surface depth (Hmax − H, the difference between the highest
height and the local height of the scanned surface) is plotted in
Figure 15 by extracting the data from the adhesion–surface
height plots of Figure 14a–x. Then the scattered data are
polymer fitted with a smooth curve. In general, the curve
shows that the obvious increase in adhesion occurs at a surface
depth of >100 nm. At depths below this value, there is no
significant change in the adhesion. However, when analyzing
the scattered data set for each CS individually, it was noticed
that the patterns of CS1, CS2, CS3, CS4, CS5, and CS6 are similar;
while CSM is different from the other CSs. As mentioned, one possible reason for this
phenomenon is that the radius of CS4 is comparable to the
primary and secondary asperity/valley radius (R) of the CM surface. In this
case, the contact area can be maximized when CS4 interacts
with the CM sample surface. As a result, the normalized adhesion of CS4–CM is higher than that of the other CS–CM pairs at the same surface depth levels as shown in Figure 15.

■ CONCLUSIONS

In the present study, a novel contact model was proposed to
correlate the adhesion force and the surface morphology by
including the primary and secondary level morphology both in
the cellulose sphere (CS) and cellulose membrane (CM) surface. The effect of the tip asperity was introduced and verified through comparing the membrane topographies obtained by CS and borosilicate sphere (BS) tips as well as the
surface morphology of these two tips. CSs of six different
sizes were used for preparing colloidal probes (CPs).
Quantitative adhesion force measurements of CS–CM interfaces were performed by employing the prepared CPs in
atomic force microscope (AFM) peak-force mode (PFM). The
theoretical adhesion forces calculated by the Johnson-Kendall-
Roberts (JKR) model were compared with the experimental
results of our adhesion measurements. The JKR model is

\[
F_{\text{JKR}} = \frac{3}{2} \pi c_s^2 \sqrt{r_{CM}}
\]

\(c_s\) is the surface energy of CS, \(c_m\) is the surface energy of CM,
and \(r_{CM}\) is the radius of CS. The surface energy of untreated
cellulose (38.5 mJ/m²) is used in eq 9 to replace the values of \(c_s\) and \(c_m\) because CS and CM are untreated pure cellulose
samples.

Moreover, the theoretical adhesion forces produced by the
JKR model have much higher values than the experimental
adhesion forces. The JKR model is known as an equilibrium
theory. In PFM experiments, the contact time between the CP
and the sample surface is <1 ms, which is much shorter than
the time needed to achieve an equilibrium. Nordgren et al.
have studied the relationship between the contact time and the
work of adhesion and surface height, which the contact surfaces are rough.

The purpose of comparing experimental values in this study
with the JKR model is to reveal the role of the CS size and the
surface morphology of the sample on adhesion variations. The adhesion calculated from the JKR model increases as the size
of the CS increases, but in real experiments, this is not
necessarily the case. CS4 and CS6 have larger radii than CS5,
but the measured adhesion is larger on CS4 than on CS5 and
CS6. Thus, the JKR model is not descriptive in the case in
which the contact surfaces are rough.

Adhesion Force and Surface Morphology. The Effect
of Tip Asperities subsection proved that the topography
and the adhesion images obtained by the CS probe are informative.
This means that the synchronously obtained sample adhesion
maps and topographies can reveal the effects of surface
morphology on adhesion forces when correlating these two
types of images. To facilitate image analysis, four-dimensional
images were assembled by adding the adhesion forces as an
extra dimension to the original three-dimensional topography
image (Figure 14a–f). Additionally, the surface height values
were extracted from the topography data and paired with the
adhesion force values for the same locations along the selected
scanning line (as marked with dotted lines in Figure 14a–l). Subsequently, the surface height and correlated adhesion are
presented together as shown in Figure 14a–x, from which it can be observed that the adhesion force peaks frequently
appear at primary and secondary valleys on the surface; this
resembles the description in the modeling part.

To investigate the numerical relationship of adhesion and
surface height, the normalized adhesion (Fadhesion/cm) as a function of surface depth (Hmax − H, the difference between the highest
height and the local height of the scanned surface) is plotted in
Figure 15 by extracting the data from the adhesion–surface

Figure 15. Normalized adhesion as a function of surface depth for
CS1–CS6.
much higher than the experimental values because of the fact that the JKR model considers only interactions between smooth surfaces at equilibrium. In addition, the calculated JKR values increase constantly as the size of the CS increases, whereas the experimental values increase initially and then start to drop. This is due to the sudden decrease in the contact area at the primary valleys when the CS becomes too large to reach the bottom of the primary valley on the CM surface, which is predicted by the proposed new contact model. The experimental adhesion—surface height plots follow the proposed adhesion—surface morphology correlation pattern, as the adhesion peak values always appear at the primary and secondary valleys on the CM surface. More experiments using cellulose materials with controlled surface roughness are required in order to build an accurate mathematical model for rough-to-rough surface interactions.

**AUTHOR INFORMATION**

Corresponding Authors
*E-mail: xiehui@hit.edu.cn.*
*E-mail: pasi.kallio@tuni.fi.*

**ORCID**

Yuli Lai: 0000-0001-8043-0155
Hui Xie: 0000-0003-4299-2776
Pasi Kallio: 0000-0001-6698-774X

**Author Contributions**

*These authors contributed equally.*

**Notes**

The authors declare no competing financial interest.

**ACKNOWLEDGMENTS**

This project was supported by BioRa, European Commission (grant number 612641), WoodBone Projects, Academy of Finland (grant number 290304), and the National Key Research and Development Program of China (grant number 2017YFA0207201). The authors thank Professor Zuobin Wang and his team, especially Yingmin Qu, of Changchun University of Science and Technology for the FIB and SEM technique support.

**REFERENCES**


